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(12) **United States Design Patent**
Liu et al.

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(54) **STAND FOR A SURGICAL MICROSCOPE**

FOREIGN PATENT DOCUMENTS

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U.S. Appl. No. 29/659,848, filed Aug. 13, 2018, Carl Zeiss Meditec AG, Jinpeng Liu et al.

(73) Assignee: **Carl Zeiss Meditec AG**, Jena (DE)

(Continued)

(**) Term: **15 Years**

Primary Examiner — Holly E Thurman

(21) Appl. No.: **29/659,856**

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(30) **Foreign Application Priority Data**

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(51) **LOC (12) Cl.** **16-06**

(52) **U.S. Cl.**

USPC **D16/131**

(58) **Field of Classification Search**

USPC D16/130–136; D24/107, 128, 137, 138,
D24/185, 186, 232, 234

CPC . G02B 21/004; G02B 21/008; G02B 21/0088
See application file for complete search history.

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(57) **CLAIM**

The ornamental design for a stand for a surgical microscope,
as shown and described.

DESCRIPTION

FIG. 1 is a perspective view of the stand for a surgical
microscope of our new design;

FIG. 2 is a left side elevation view of the stand for a surgical
microscope of FIG. 1;

FIG. 3 is a right side elevation view of the stand for a
surgical microscope of FIG. 1;

FIG. 4 is a front elevation view of the stand for a surgical
microscope of FIG. 1;

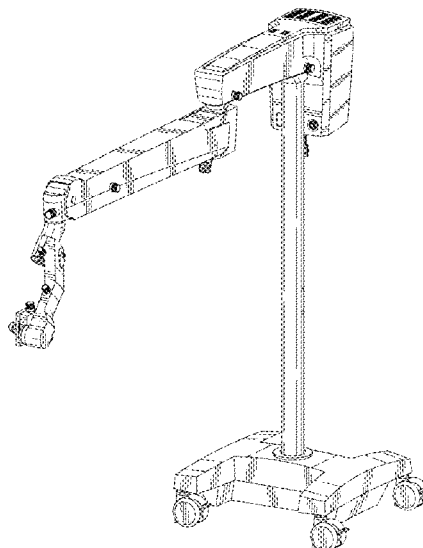
FIG. 5 is a rear elevation view of the stand for a surgical
microscope of FIG. 1;

FIG. 6 is a top plan view of the stand for a surgical
microscope of FIG. 1; and,

FIG. 7 is a bottom plan view of the stand for a surgical
microscope of FIG. 1.

The broken lines depict portions of the stand for a surgical
microscope that form no part of the claimed design.

1 Claim, 7 Drawing Sheets



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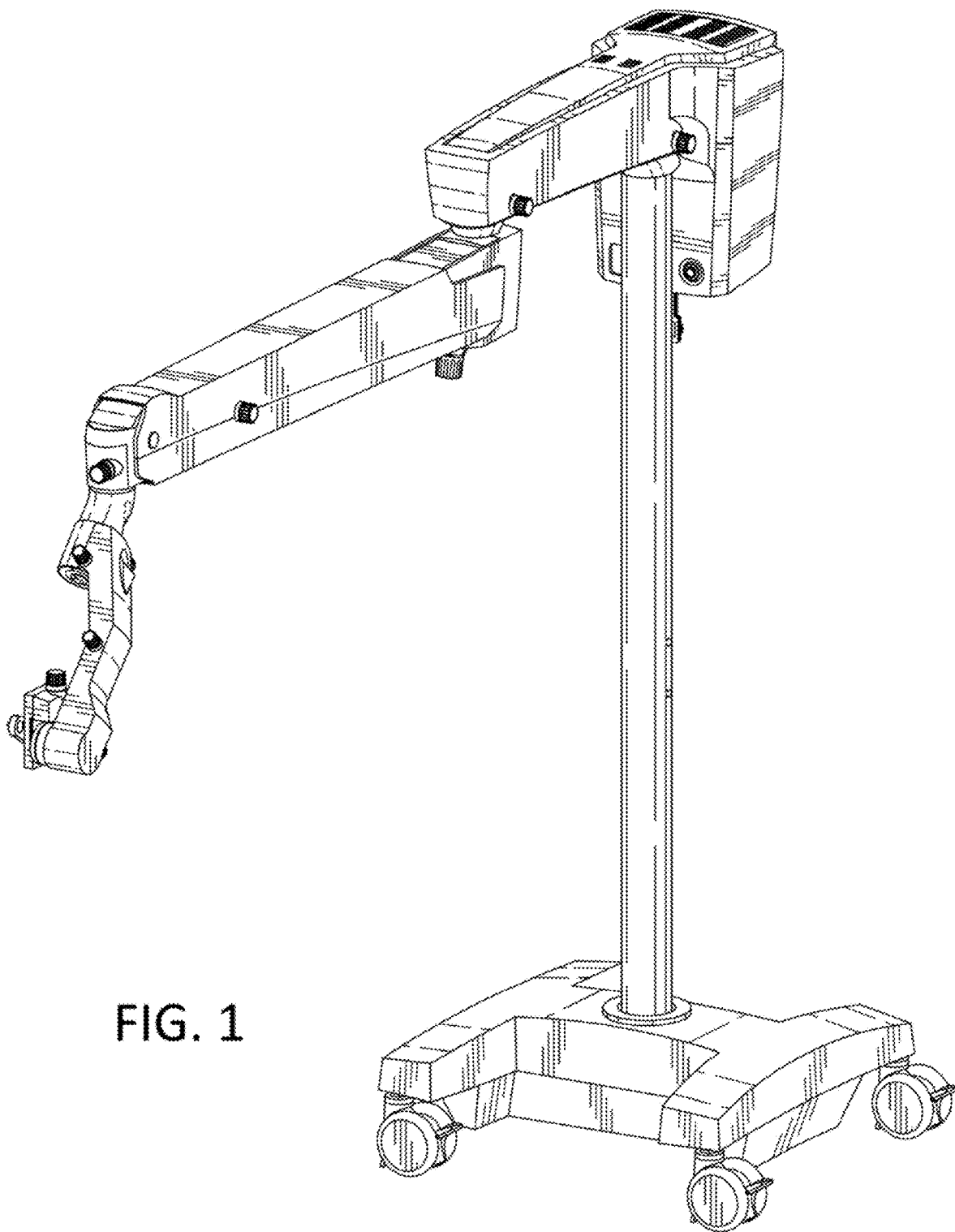


FIG. 1

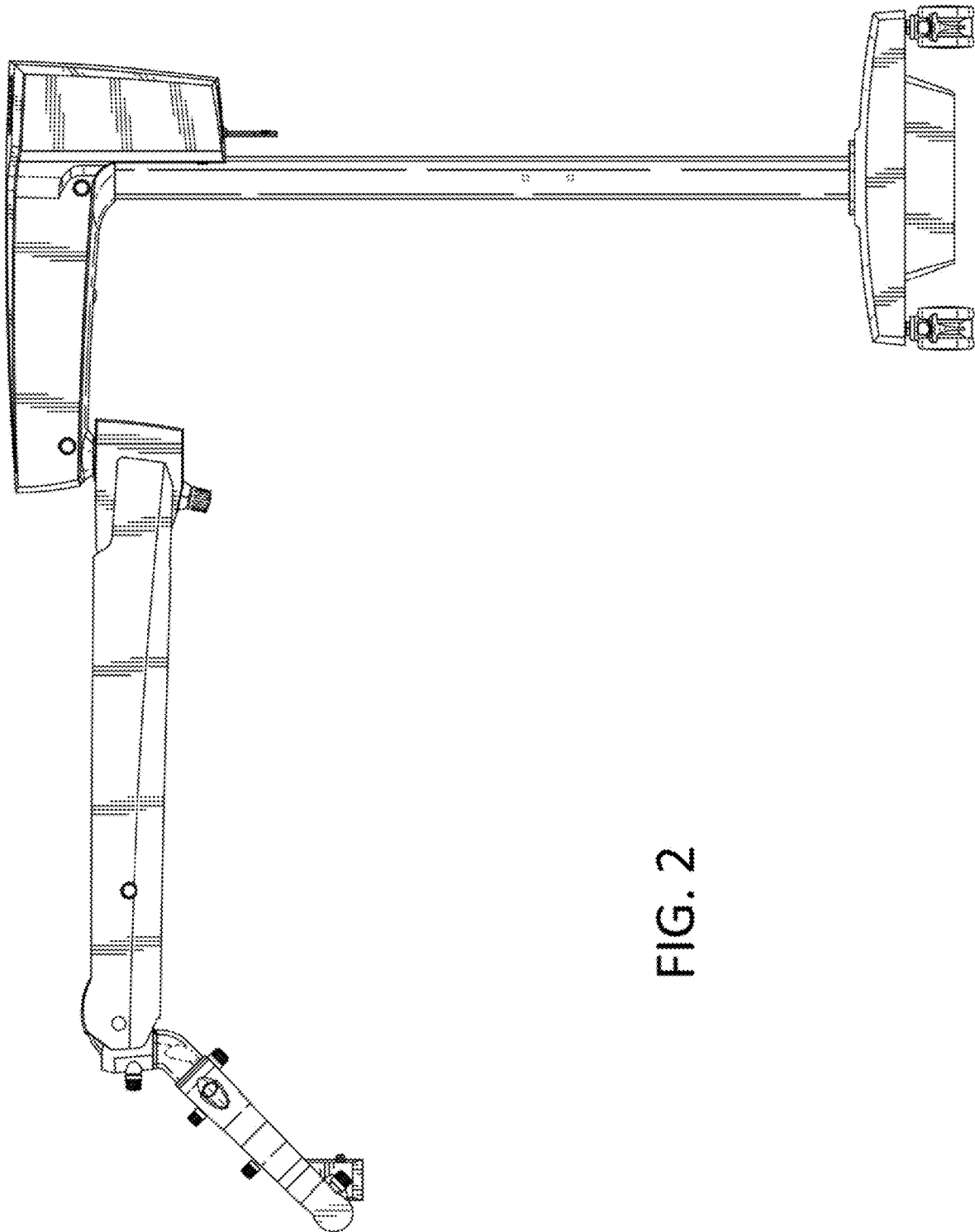
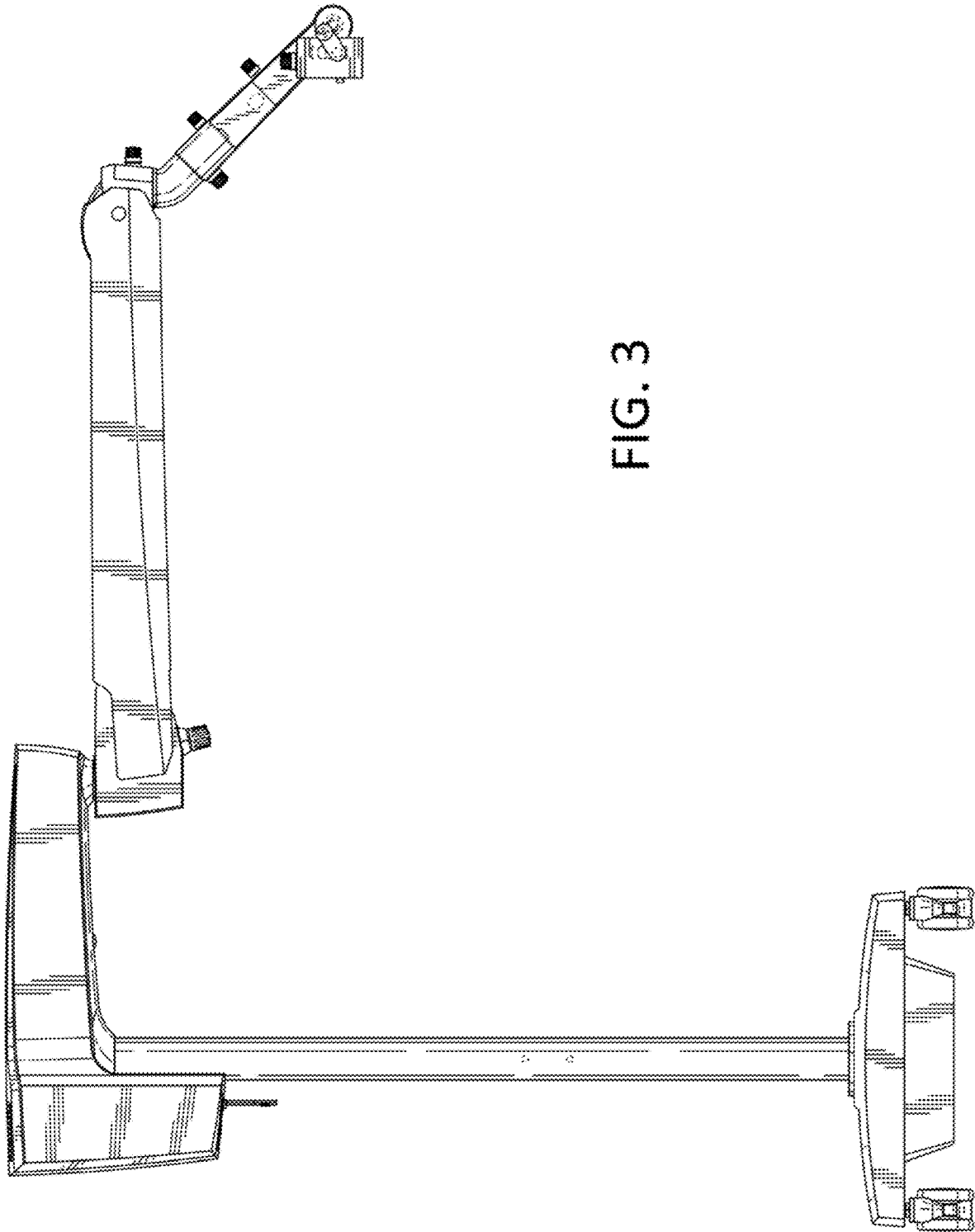


FIG. 2



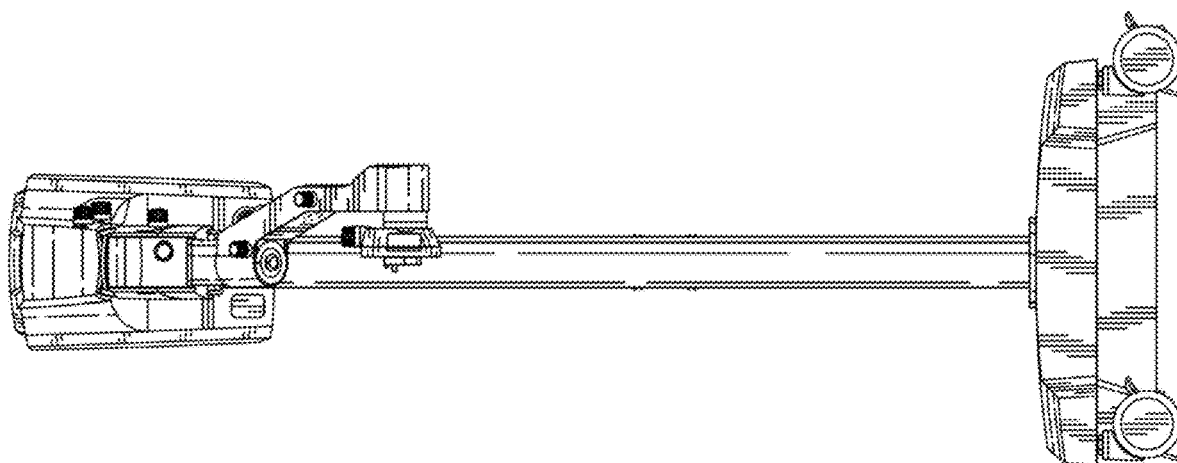


FIG. 4

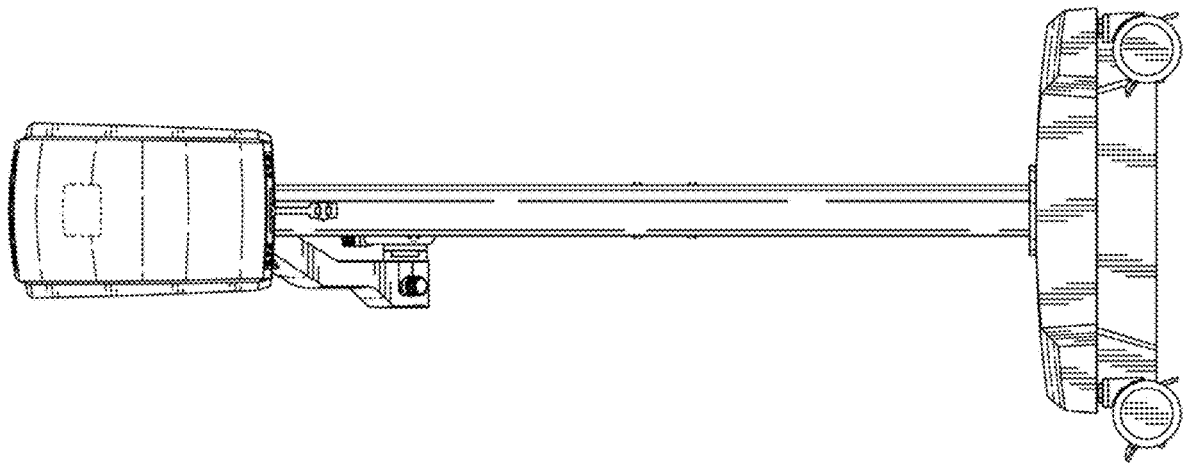


FIG. 5

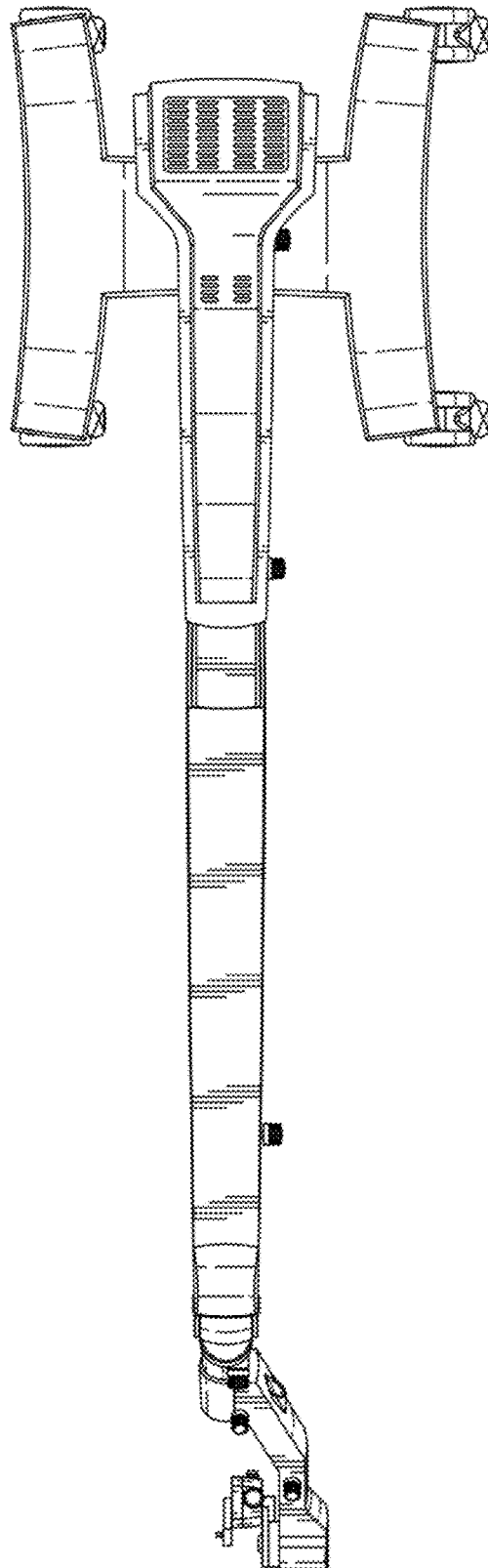


FIG. 6

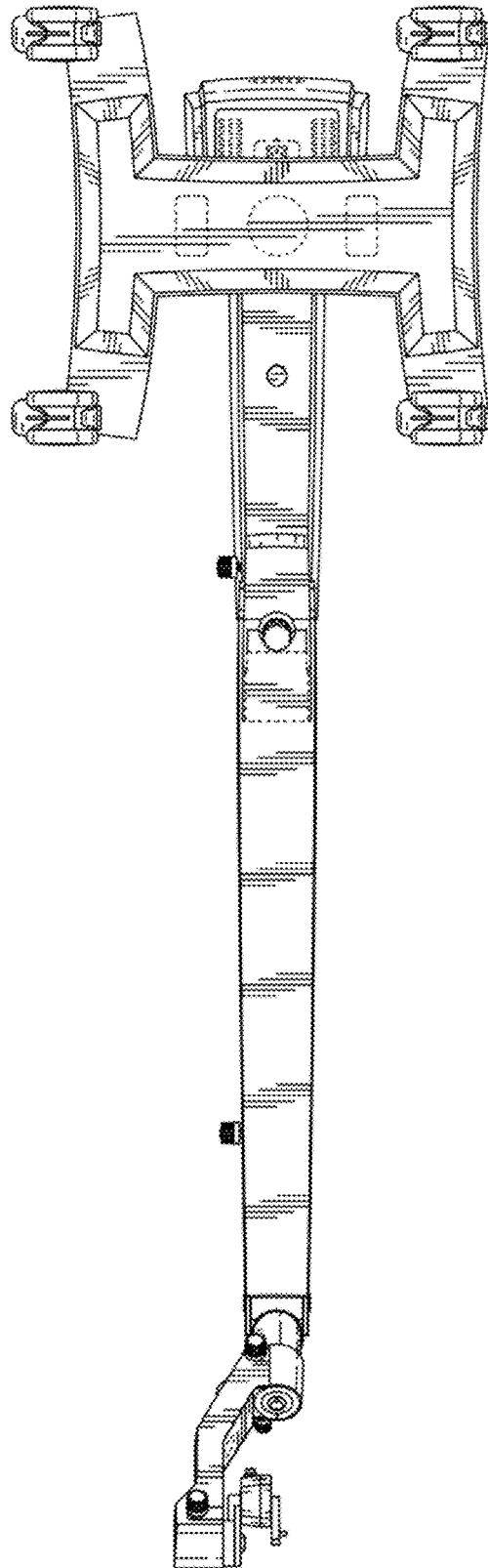


FIG. 7